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**Aerobic Oxidation of Arsenite to Arsenate by Cu(II)-
chitosan/O₂ in Fenton-like Reaction, a XANES Investigation**

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Water impact statement:

Fenton(-like) reactions are widely used in water treatment applications to oxidize and degrade organic pollutants; however, oxidation of inorganic contaminants via Fenton(-like) processes has been much less frequently studied. In this study, As(III) is used as a probe molecule to demonstrate the successful oxidation of As(III) to As(V) by Cu(II)-chitosan via a Fenton-like reaction.

1 Aerobic Oxidation of Arsenite to Arsenate by Cu(II)-chitosan/O₂ in Fenton-like Reaction, a
2 XANES Investigation

3

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16

17 Abstract

18 Oxidation of inorganic molecules (e.g., arsenite (As(III)) to arsenate (As(V))) by Cu(II)-
19 chitosan in the presence of dissolved oxygen is examined to elucidate the ability and mechanism
20 of Cu(II)-chitosan and Cu(II)-n-TiO₂-chitosan participation in Fenton-like reactions. To form the
21 Cu(II)-chitosan complex, Cu(II) binds with the amine groups of the chitosan backbone resulting
22 in a Cu(II)-complex with cationic behavior. Arsenic is then adsorbed to the copper binding site
23 through a combination of Lewis acid-base coordinate bonding and electrostatics. As K-edge
24 XANES indicate that arsenite is fully oxidized to arsenate when adsorbed to a Cu(II)-chitosan
25 complex in the dark without introduction of a photo- or chemical-oxidant. The oxidation of
26 arsenite by this complex is strongly controlled by the presence of dissolved oxygen as suggested
27 by linear combination fitting where the %As(V) bound decreases from 100% ± 0.0% to 60.2 ±
28 0.1% upon removal of dissolved oxygen via the freeze pump thaw method. Cu K-edge XANES
29 indicate that Cu(II) acts as a catalyst rather than a reactant, as it remains present as Cu(II) after
30 As oxidation in each system condition examined. For Cu(II)-n-TiO₂-chitosan, the amount of
31 As(III) oxidized to As(V) is strongly controlled by the loading of Cu(II), with a higher loading of
32 Cu(II) leading to more As(III) oxidized and bound on the surface of the adsorbent as As(V).

33 As(III) removal by both Cu(II)-chitosan and Cu(II)-nTiO₂-chitosan are significantly improved
34 due to the Fenton-like oxidation of As(III) to As(V). For Cu(II)-n-TiO₂-chitosan, higher loadings
35 of Cu(II) relative to n-TiO₂ lead to greater improvement of As(III) removal performance in oxic
36 vs anoxic conditions.

37

38 Key words: arsenic, adsorption, Cu(II), Fenton-like, oxidation; chitosan

39

40 1. Introduction

41 Fenton and Fenton-like reactions have been widely used within advanced oxidation processes
42 (AOPs) as an effective means to oxidize organic contaminants with high chemical stability
43 and/or low biodegradability, converting them into less toxic or more easily biodegradable
44 molecules.^{1,2} Iron catalyzed Fenton reactions can also be utilized to oxidize or reduce inorganic
45 contaminants, (e.g., As(III); Cr(VI)) into their less toxic and more easily removed oxidation
46 states.^{3,4} Benefits of using Fenton-type chemistry include short reaction times, lack of waste
47 generation, and the use of relatively inexpensive and environmentally benign materials (e.g.,
48 hydrogen peroxide) and low-cost metals, (e.g., iron and copper).^{2,5} In a traditional Fenton
49 reaction, Fe(II) first reacts with H₂O₂ to form a Fe(II)-peroxide complex.⁶ This complex then
50 decomposes into reactive oxidants, either hydroxyl radicals or Fe(IV)⁶ that can oxidize various
51 compounds.

52 Less frequently studied than traditional iron catalyzed Fenton reactions are Fenton-like
53 reactions involving other transition metals such as, Cu(II), which can similarly react with H₂O₂
54 to form reactive oxidants in the form of hydroxyl radicals and Cu(III). These reactive oxidants
55 are pH dependent with hydroxyl radicals more commonly produced in acidic conditions and
56 Cu(III) in neutral and alkaline conditions.^{6,7} Cu(II) catalyzed Fenton-like reactions have been
57 used successfully to oxidize and degrade various organic compounds including acetaminophen,⁸
58 benzoate,^{6,7} phenol,⁶ and methanol;⁶ however, inorganic contaminants, such as arsenic, have not
59 yet been reported to be successfully oxidized via a Cu(II) catalyzed Fenton-like reaction.

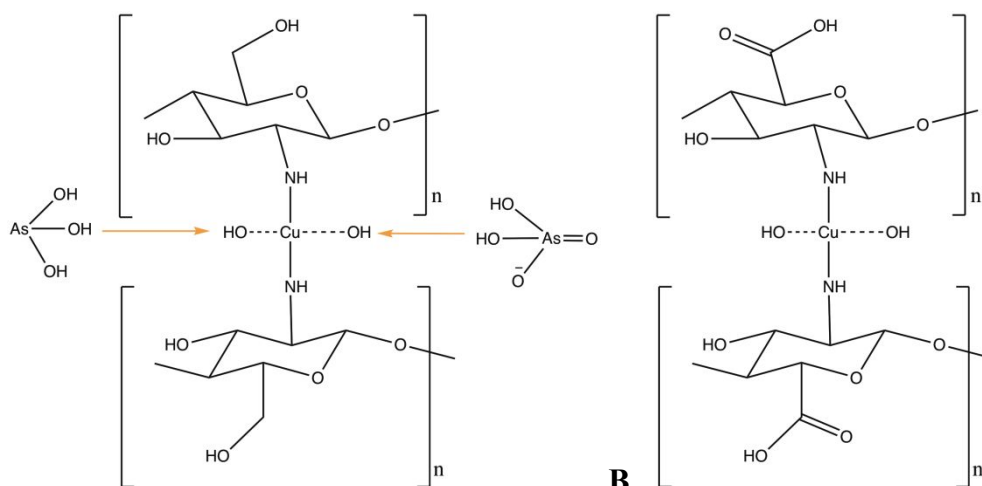
60 Arsenic is a toxic and carcinogenic metalloid that can be released into waters both naturally
61 and anthropogenically.⁹⁻¹¹ The forms of arsenic predominantly found in aqueous environments are
62 arsenite (As(III)) and arsenate (As(V)).¹⁰ At pH 5-7, As(V) tends to be negatively charged
63 (H₂AsO₄⁻ and HAsO₄²⁻). In contrast, As(III), the more toxic form of arsenic, is typically

64 uncharged (H_3AsO_3), making it more difficult to remove.^{12,13} Therefore, arsenite is commonly
65 oxidized to arsenate as a pre-treatment step^{14–16}. One of the most frequently used techniques is
66 photo-catalysis of As(III) to As(V) by n-TiO₂ in UV light. This oxidation reaction occurs as
67 follows: 1. Superoxide radicals are generated on the surface of n-TiO₂ under UV light react with
68 As(III) to produce As(IV) radicals, 2. Molecular oxygen, hydroxyl radicals, or a trapped hole
69 react with As(IV), oxidizing it to As(V).^{15,17} While this method of arsenic oxidation is effective,
70 it can be challenging to incorporate UV light into a flow-through water treatment systems at a
71 reasonable scale.¹⁸

72 An alternative technique to photooxidation of As(III) to As(V) is Fenton and Fenton-like
73 reactions using Fe(II) ions and hydrogen peroxide.^{6,19,20} However, in the case of Cu(II) Fenton-
74 like reactions, Cu(II) ions and H₂O₂ were unable to oxidize As(III) to As(V) except in high
75 alkalinity conditions, likely due to the low reaction rate.⁶ One technique to overcome this barrier
76 that has been reported is the addition of hydroxylamine, a reducing agent, into the Cu(II)/H₂O₂
77 system which accelerates the rate of Cu(II) reduction, as well as the production of reactive
78 oxidants by Cu(II)/H₂O₂.^{6,7} Specifically, Cu(II) and hydroxylamine will generate hydrogen
79 peroxide through the reduction of dissolved oxygen, which has been reported to result in greater
80 degradation of benzoic acid compared to Cu(II) alone.^{6,7} The results of these studies indicate that
81 introduction of organic compounds that act as reducing agents can enhance the effectiveness of
82 Cu(II) Fenton-like reactions.

83 In this study, we will examine the potential of Cu(II)-chitosan and Cu(II)-n-TiO₂-chitosan to
84 participate in Fenton-like reactions to oxidize inorganic contaminants. Cu(II)-chitosan and
85 Cu(II)-n-TiO₂-chitosan have previously been successfully utilized as adsorbents to remove
86 As(V) and As(III).^{18,21,22} As the Cu(II)-chitosan complex gains cationic behavior upon
87 complexation of Cu(II),^{18,21–25} As(V) is adsorbed through a combination of electrostatics and
88 Lewis acid-base coordinate bonding (Figure 1A).^{21,26,27} As(III), since it is neutrally charged in
89 most environmental conditions, is adsorbed through Lewis acid-base coordinate
90 bonding.^{18,21,22,26–29}

91



92

A.

B.

93 **Figure 1. A.** Adsorption of As(III) and As(V) by Cu(II)-chitosan. **B.** Oxidation of chitosan under UV light as
 94 proposed by Miller et al. (2011)³⁰.

95

96 Given the previous success utilizing Cu(II)-chitosan and Cu(II)-n-TiO₂-chitosan as
 97 adsorbents for arsenic,^{18,21,22} As(III) is employed as a probe molecule to elucidate the underlying
 98 mechanism and the ability of these adsorbents to participate in Fenton-like reactions to oxidize
 99 inorganic contaminants. The effect of the Fenton-like oxidation on the arsenic removal capability
 100 of Cu(II)-chitosan and Cu(II)-n-TiO₂-chitosan is also examined.

101

102 2. Materials and Methods

103 *Standards and Reagents*

104 Beads of Cu(II)-chitosan and Cu(II)-n-TiO₂-chitosan were synthesized from chitosan (TCI
 105 America, 200-500 mPa-s, 0.5% in acetic acid), Cu(NO₃)₂·3H₂O (Sigma Aldrich) and nano-TiO₂
 106 anatase (Sigma Aldrich, < 25 nm)^{21,22}. Nitric acid and sodium hydroxide used during the
 107 synthesis were prepared from a concentrated stock solution (Fisher Scientific, trace metal grade),
 108 and NaOH pellets (JT Baker, ACS reagent grade), respectively.

109 Arsenate stock solutions (100 ppm) were prepared using Na₂HAsO₄·7H₂O (Fisher Scientific,
 110 >99.5%), and arsenite using NaAsO₂ (Fluka, >99.0%). Phosphate stock solution was prepared
 111 from NaH₂PO₄·H₂O (JT Baker, ACS reagent grade), phosphoric acid (Sigma Aldrich, trace
 112 metal grade), and DI water^{21,22}. NaCl was prepared from NaCl salt (Sigma Aldrich, ACS reagent
 113 grade). HCl was prepared from concentrated stock solution (JT Baker, ACS reagent grade).
 114 Acetate buffer pH 6 (1 M) was prepared from glacial acetic acid (Fisher Scientific, ACS reagent
 115 grade) and sodium acetate anhydrous (CH₃COONa) (JT Baker, ACS reagent grade). To prepare

116 anoxic stock solutions, salts of As(III), As(V), NaCl, and NaOH were added to degassed water
117 within the glovebox.

118

119 *Adsorbent Synthesis*

120 Cu(II)-chitosan and Cu(II)-n-TiO₂-chitosan were synthesized as follows by adapting the
121 procedures of Yamani et al. (2016) and Pincus et al. (2018).^{21,22} For the Cu(II)-chitosan, 0.40 g
122 Cu(NO₃)₂·3H₂O and 1 g chitosan were added to 0.1 M HNO₃ and stirred overnight. For Cu(II)-n-
123 TiO₂-chitosan, after stirring overnight, n-TiO₂ was added, and the mixture stirred for another 24
124 hours. Two versions of Cu(II)-n-TiO₂-chitosan were synthesized, Cu(II)-n-TiO₂-chitosan A (0.40
125 g Cu(NO₃)₂·3H₂O, 0.30 g n-TiO₂ / g chitosan) and Cu(II)-n-TiO₂-chitosan B (0.36 g Cu(NO₃)₂-
126 3H₂O and 0.60 g n-TiO₂ / g chitosan). Next, a syringe pump fitted with an 18G needle was used
127 to push droplets into 0.1 M NaOH. The solidified droplets were rinsed until filtrate was of
128 neutral pH and then air-dried.

129

130 *Arsenic Oxidation Experiments*

131 The ability of Cu(II)-chitosan and Cu(II)-n-TiO₂-chitosan to oxidize As(III) was examined
132 through week-long batch incubations followed by XANES analysis. For the batch experiment,
133 100 mg of Cu(II)-chitosan or Cu(II)-n-TiO₂-chitosan was added to 40 mL of solution in a 50-mL
134 polypropylene falcon tube. Five systems conditions were analyzed, As(V), As(III) in dark oxic
135 conditions, As(III) in dark anoxic conditions, As(III) + P in dark oxic conditions, and As(III) in
136 UV light. The initial concentrations of As and P were 44 ppm As and 56 ppm P, so as to ensure
137 full saturation of the adsorbent with arsenic resulting in a good signal to noise ratio in XANES
138 analysis. 0.01 M NaCl was added as a background electrolyte.

139 Samples were incubated at 150 rpm and 25 °C for one week in VWR shaking incubators. pH
140 was adjusted to 6 ± 0.15 daily using 0.1 M NaOH and 0.1 M HCl. For UV light incubations, an 8
141 W, 365 nm, UV lamp was suspended 18” above the samples. For anoxic incubations all sample
142 preparation was done within a glovebox with a N₂ atmosphere. To prepare anoxic DI water, the
143 freeze pump thaw method was utilized.³¹ DI water was added to a sealed Schlenk tube connected
144 to Schlenk line and frozen using liquid N₂. Once the DI water was completely frozen, the flask
145 was opened to vacuum and then gradually thawed in room temperature water. This cycle was
146 repeated four times before bringing the degassed DI water into the glovebox. An Extech 407510

147 dissolved oxygen (DO) meter (± 0.4 mg/L DO accuracy) was utilized to ensure no dissolved
148 oxygen was present in any stock or incubation solutions. For the anoxic incubations, the copper-
149 chitosan was added to the anoxic solutions within the glovebox and all daily pH adjustments
150 occurred within the glovebox using anoxic HCl and NaOH solutions. Following incubation, the
151 solutions were decanted and the samples were then frozen until time of XANES analysis.

152

153 *As K-edge XANES analysis*

154 In order to assess oxidation state of arsenic present on the surface of Cu(II)-chitosan and
155 Cu(II)-n-TiO₂-chitosan, X-ray Adsorption Near Edge Spectroscopy (XANES) was utilized. The
156 frozen beads were sealed in Kapton tape for analysis with care taken to minimize pinholes.
157 Anoxic samples were sealed in Kapton tape within a glovebox and then placed in a N₂
158 atmosphere glovebag during analysis.

159 XANES spectra were collected at the As K-edge (11867 eV) and Cu K-edge (8979 eV) at the
160 Inner Shell Spectroscopy beamline (8-ID) at the National Synchrotron Light Source II (NSLS II)
161 at Brookhaven National Laboratory and the As K-edge at beamline 9-BM at the Advanced
162 Photon Source (APS) at Argonne National Laboratory. As K-edge spectra were calibrated to the
163 Au L-edge (11919 eV) using an Au reference foil.³² Cu K-edge spectra were calibrated using a
164 Cu foil. Multiple scans were collected and averaged to improve the signal to noise ratio. At
165 NSLS II, the electron storage ring operated at 3 GeV with a 400 mA beam current. Spectra were
166 acquired in fluorescence mode at room temperature using a cryogenically cooled Si (111)
167 Double Crystal monochromator and a Passivated Implanted Planar Silicon (PIPS) detector. A
168 germanium Z-1 filter was used to suppress the elastic scattering on the detector. At APS, the
169 electron storage ring operated at 7 GeV with a 100 mA beam current. Samples were kept at 20 K
170 using a liquid helium flow cryostat and spectra acquired in fluorescence mode using a 4-element
171 Vortex Silicon Drift Detector (SDD).

172 Data reduction and analysis were performed using the Athena program.³³ Linear combination
173 fitting (LCF) performed using the Athena program was used to determine relative percentages of
174 arsenate and arsenite adsorbed to each sample.^{33,34} The standards used for As(III) and As(V)
175 were 100 mMol solutions of sodium arsenite and sodium arsenate dibasic heptahydrate,
176 respectively. Uncertainties of fit reported were calculated by Athena as $R\text{-Factor} = \frac{\sum(\text{data} - \text{fit})^2}{\sum(\text{data}^2)}$,
177 where an R-Factor < 0.05 is considered a reasonable fit.^{33,35}

178

179 *Arsenic Adsorption Experiments*

180 Week-long batch incubations were utilized in order to examine the arsenic removal
181 capability.^{12,18,21,22,30,36,37} The adsorbents were added to 40 mL of solution in a 50-mL
182 polypropylene Falcon tube. The following systems conditions were analyzed: As(V) dark,
183 As(V)+P dark, As(III) dark, As(III)+P dark, As (III) UV, As (III)+P UV, and As(III) dark
184 anoxic. In each systems condition, the initial concentration of arsenic was varied. Phosphate was
185 chosen as a competitive oxyanion due to its ability to strongly compete with arsenic for
186 adsorption sites.³⁸ When phosphate was present, the initial concentration was 16 ppm. A 25 mM
187 acetate buffer pH 6 was added to maintain constant pH.^{18,21,22} All anoxic experiments were done
188 in an N₂ atmosphere using the methods described in Section 2.3. The incubation methods also
189 follow the procedure outlined in Section 2.3 except that daily pH adjustments were not done due
190 to the use of the acetate buffer pH 6.

191 Prior to analysis, samples were filtered using a 0.22- μ m PVDF filter and diluted with 1%
192 nitric acid. A Perkin Elmer DRC-e inductively coupled plasma-mass spectrometry (ICP-MS) was
193 used to analyze the samples. A Scott Crossflow nebulizer with mixing tee, Argon plasma, and
194 germanium and scandium internal standards were utilized during the analysis.^{21,22} Triplicate
195 analyses were performed with a repeating standard and blank every ten samples to track
196 instrument stability.

197

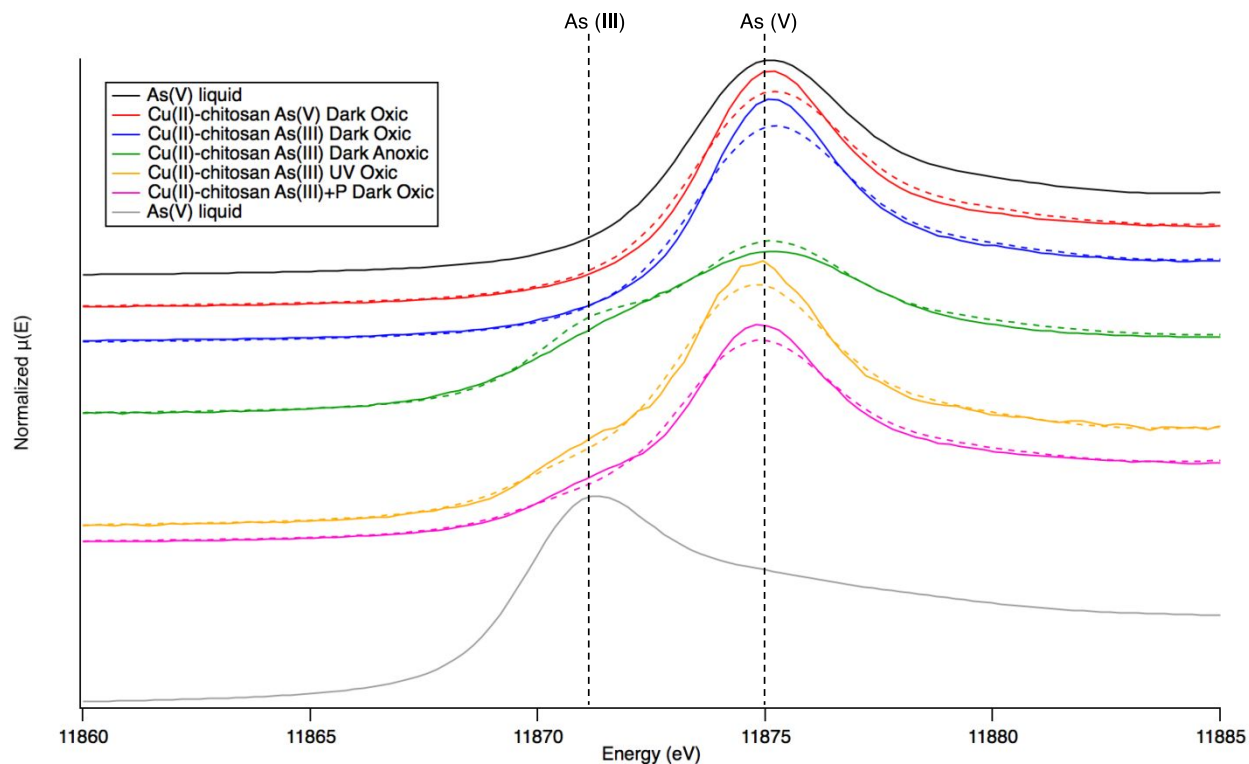
198 3. Results and Discussion

199 3.1 Assessment of As oxidation state via As K-edge XANES

200 As K-edge XANES were utilized to analyze speciation of arsenic adsorbed to the surface of
201 Cu (II)-chitosan. E₀, measured as the white line, was found to be 11871.7 eV for As(III) and
202 11875.1 eV for As(V) (Figure 2). By fitting XANES spectra to liquid standards of 100 mMol
203 As(III) and As(V) using LCF analysis in Athena, the relative speciation of adsorbed arsenic can
204 be quantified.^{33,34} R-factors below 0.05 indicate goodness of fit by LCF (Table 1).^{33,35}

205 As K-edge XANES indicate that As(V) does not undergo any redox reactions upon binding
206 to Cu(II)-chitosan and is adsorbed as As(V) (Figure 2, Table 1). In contrast, As(III) is fully
207 oxidized to As(V) (100% \pm 0.0) upon binding to Cu(II)-chitosan in the dark in oxic conditions.

208 This result confirms that Cu(II)-chitosan is capable of oxidizing As(III) to As(V) without the
209 addition of a photo- or chemical-oxidant.



210
211 **Figure 2.** Stacked and normalized As K-edge XANES spectra for Cu(II)-chitosan (0.4 g Cu / g chitosan)
212 incubated in various systems conditions and 100 mMol As(V) and As(III) liquid standards. Data is shown
213 with solid lines, fits generated by LCF analysis in Athena are shown as dashed lines.

214
215 **Table 1.** Results of Linear Combination Fitting Showing Combinations of Standards Yielding the Best Fits
216 to Cu(II)-Chitosan Arsenic K-Edge XANES

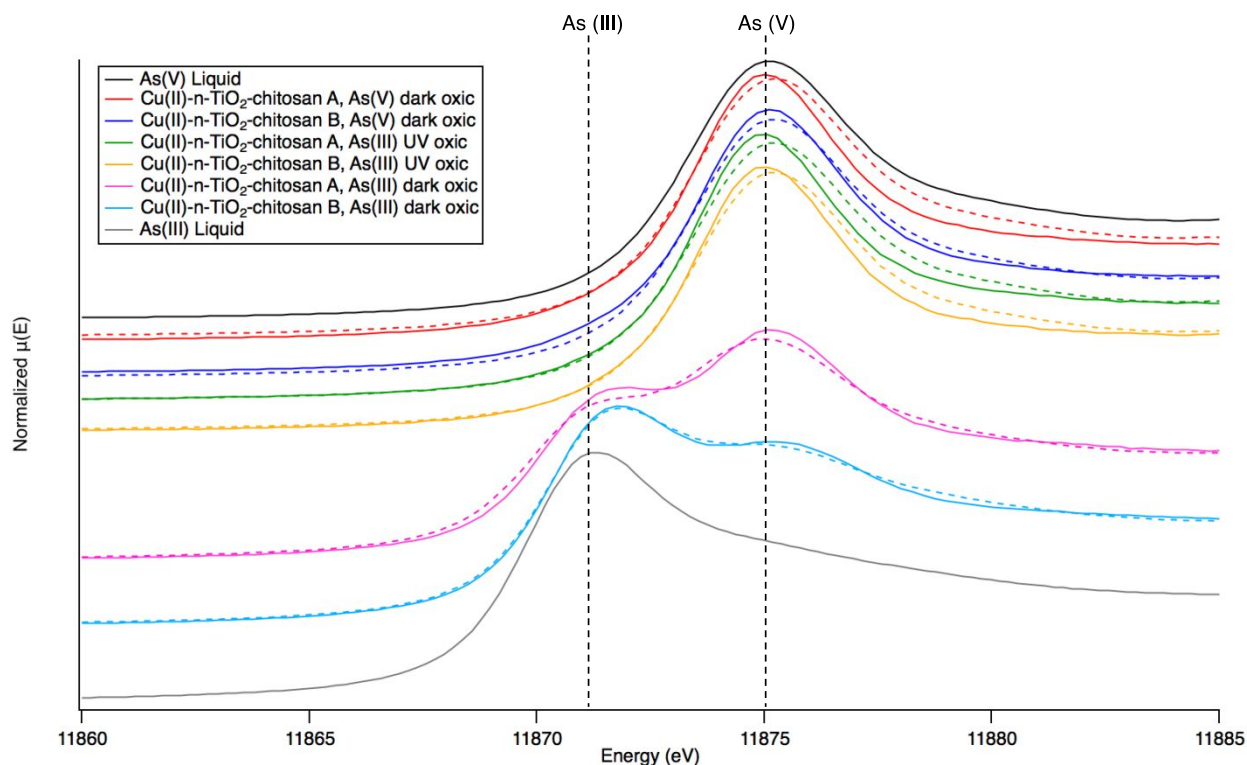
System Condition	% As(V)	% As(III)	R-Factor ^a
As V Dark Oxidic	100 ± 0.0	0.00 ± 0.0	0.007
As III Dark Oxidic	100 ± 0.0	0.00 ± 0.0	0.009
As III Dark Anoxic	60.2 ± 0.1	39.8 ± 0.1	0.005
As III UV Oxidic	86.9 ± 0.1	13.1 ± 0.1	0.008
As III + P Dark Oxidic	90.0 ± 0.1	10.0 ± 0.1	0.005

217 ^aUncertainties of fit reported were calculated by Athena as $R\text{-Factor} = \Sigma(\text{data} - \text{fit})^2 / \Sigma(\text{data}^2)$.

218
219 As K-edge XANES analysis of Cu(II)-n-TiO₂-chitosan A (0.4 g Cu(NO₃)₂·3H₂O, 0.30 g
220 n-TiO₂ / g chitosan) and Cu(II)-n-TiO₂-chitosan B (0.36 g Cu(NO₃)₂·3H₂O and 0.60 g n-TiO₂ / g
221 chitosan) was also performed (Figure 3). As expected, no redox transformations were observed
222 post-adsorption of As(V) by Cu(II)-n-TiO₂-chitosan A or B (Figure 3, Table 2). Following
223 incubation in UV light, As(III) was fully photo-oxidized to As(V) by Cu(II)-n-TiO₂-chitosan A
224 and B prior to adsorption, and thus, is bound fully as As(V). This is expected since n-TiO₂ is a

225 known photo-oxidant of As(III) in UV light.^{12,18,21,30,36,39,40} Interestingly, following incubation in
 226 darkness, As(III) is present on the surface of Cu(II)-n-TiO₂-chitosan A and B as a mixture of
 227 As(III) and As(V) (Figure 3). For Cu(II)-n-TiO₂-chitosan A, As(III) was present as 50.7 ± 0.1%
 228 As(V) (Table 2). In contrast, Cu(II)-n-TiO₂-chitosan B had only 17.3 ± 0.1% As(V) present on
 229 the surface. The amount of As(V) vs As(III) on the surface of both beads correlates with the
 230 relative loading of Cu(II) rather than n-TiO₂.

231



232

233 **Figure 3.** Stacked and normalized As K-edge XANES spectra for Cu(II)-n-TiO₂-chitosan A (0.40 g Cu,
 234 0.30 g nTiO₂ / g chitosan) and Cu(II)-n-TiO₂-chitosan B (0.36 g Cu, 0.60 g nTiO₂ / g chitosan) incubated in
 235 various systems conditions and 100 mMol As(V) and As(III) liquid standards. Data is shown with solid
 236 lines, fits generated by LCF analysis in Athena are shown as dashed lines.

237

238 **Table 2.** Results of Linear Combination Fitting Showing Combinations of Standards Yielding the Best Fits
 239 to Cu(II)-n-TiO₂-Chitosan Arsenic K-Edge XANES

Sample	System Condition	% As(V)	% As(III)	R-Factor ^a
Cu(II)-n-TiO ₂ A	As V Dark Oxic	100 ± 0.0	0.00 ± 0.0	0.008
	As III UV Oxic	100 ± 0.0	0.00 ± 0.0	0.009
	As III Dark Oxic	50.7 ± 0.1	49.3 ± 0.1	0.004
Cu(II)-n-TiO ₂ B	As V Dark Oxic	100 ± 0.0	0.00 ± 0.0	0.005
	As III UV Oxic	100 ± 0.0	0.00 ± 0.0	0.008
	As III Dark Oxic	17.3 ± 0.1	82.7 ± 0.1	0.001

240 ^aUncertainties of fit reported were calculated by Athena as R-Factor = $\sum(\text{data} - \text{fit})^2 / \sum(\text{data}^2)$.

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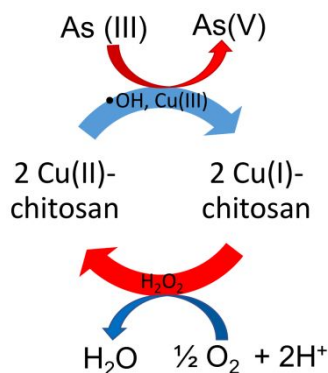
244 3.2 Oxidation of As(III) to As(V) via Fenton-like reaction mechanism

245 In order to assess the role of dissolved oxygen in the reaction mechanism, an incubation was
246 conducted in a N₂ atmosphere with stock solutions degassed using the freeze pump thaw
247 method.³¹ Upon removal of dissolved oxygen, As(III) is adsorbed to Cu(II)-chitosan as a mixture
248 of As(V) ($60.2 \pm 0.1\%$) and As(III) ($39.8 \pm 0.1\%$), as compared to in oxic conditions where
249 As(III) is bound to Cu(II)-chitosan $100\% \pm 0.0\%$ as As(V) (Figure 2, Table 1). The inhibitory
250 effect of removal of dissolved oxygen suggests that oxidation of As(III) to As(V) occurs through
251 a Cu(II)-chitosan Fenton-like reaction.^{8,41}

252 It is hypothesized that in this Fenton-like reaction, chitosan acts as a reducing agent, similar
253 to hydroxyl amine, accelerating the rate of Cu(II) reduction and production of hydrogen peroxide
254 from dissolved oxygen.^{7,42} The H₂O₂, then forms reactive complexes with Cu(II)-chitosan to
255 produce hydroxyl radicals and Cu(III).^{6,41} These reactive oxidants in turn oxidize As(III) to
256 As(V). Overall, the proposed mechanism in the system is that Cu(II)-chitosan/O₂ act as a two-
257 electron oxidant oxidizing As(III) to As(V) and reducing dissolved O₂ to H₂O (Figure 4).⁴¹

258 While this specific reaction mechanism has not been previously analyzed, these results agree
259 with earlier studies of related Fenton and Fenton-like reactions where it has been shown that
260 Cu(II) Fenton-type reactions with H₂O₂ or hydroxylamine serving as the reducing agent are
261 capable of oxidizing various organic compounds such as acetaminophen,⁸ benzoate,^{6,7} phenol,⁶
262 and methanol.⁶ Oxidation of As(III) to As(V) via Fe(II)/H₂O₂ systems where hydrogen peroxide
263 is the reducing agent have been previously analyzed and found to be successful.^{6,19} However, a
264 Cu(II)/H₂O₂ systems comprised of 0.1 mM Cu(II) ions and 0.2 mM H₂O₂ was found to be
265 unsuccessful for oxidation of As(III) in a study by Lee et al. (2013). This suggests the
266 importance of chitosan as a reducing agent in the system to enhance the rate of Cu(II) reduction
267 within the Cu(II)-chitosan oxidation mechanism.^{7,42}

268



269
 270 **Figure 4.** Proposed mechanism for As(III) oxidation by Cu(II)-chitosan through a Fenton-like reaction.
 271 Blue arrows indicate reduction reactions and red arrows indicate oxidation reactions.
 272

273 3.3 Inhibition of As(III) oxidation by UV light and phosphate

274 Incubation in UV light resulted in slight inhibition of the As(III) oxidation with As(III)
 275 bound on the surface as $86.9 \pm 0.1\%$ As(V) and $13.1 \pm 0.1\%$ As(III) (Figure 2, Table 1). UV
 276 light is known to affect the structure of chitosan, transforming hydroxyl groups into carboxyl
 277 groups (Figure 1B).^{30,43} Thus, structural changes to the chitosan backbone have a negative effect
 278 on the ability of Cu(II)-chitosan to oxidize As(III) to As(V), suggesting the involvement of
 279 chitosan in this oxidation reaction.

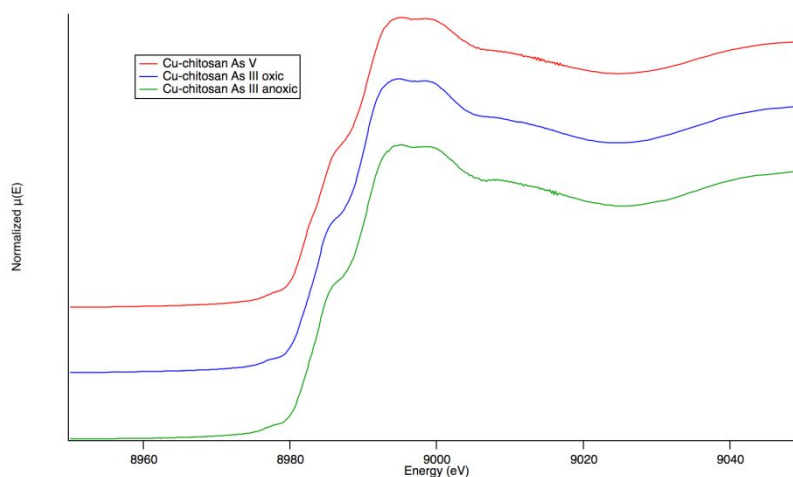
280 Addition of phosphate had a slight inhibitory effect on the oxidation of As(III), decreasing
 281 %As(III) oxidized to As(V) from $100\% \pm 0.0\%$ to $90.0 \pm 0.1\%$ (Figure 2, Table 2). This
 282 inhibitory effect is potentially due to poisoning of Cu(II) as a catalyst by phosphate. While not
 283 yet demonstrated for Cu(II)-chitosan or specifically for Fenton-like reactions, phosphate is
 284 known to inhibit Cu(II)-catalysis.^{44,45}

285

286 3.4 Analysis of copper oxidation state via Cu K-edge XANES

287 To confirm the role of Cu(II) as a catalyst, Cu K-edge X-ray adsorption near edge
 288 spectroscopy (XANES) were utilized to analyze the oxidation state of Cu within Cu(II)-chitosan
 289 under various systems conditions. The oxidation state of copper was unaffected by changes in
 290 system conditions, remaining bound as Cu(II) for incubation in As(V), As(III) oxic conditions,
 291 and As(III) anoxic conditions (Figure 5). As these XANES analyses were conducted once the
 292 As(III)-Cu(II)-chitosan system reached equilibrium, it would be expected that Cu(II) would be
 293 present as Cu(II) given its role as a catalyst that would be regenerated at the end of the oxidation
 294 reaction, rather than a reactant.

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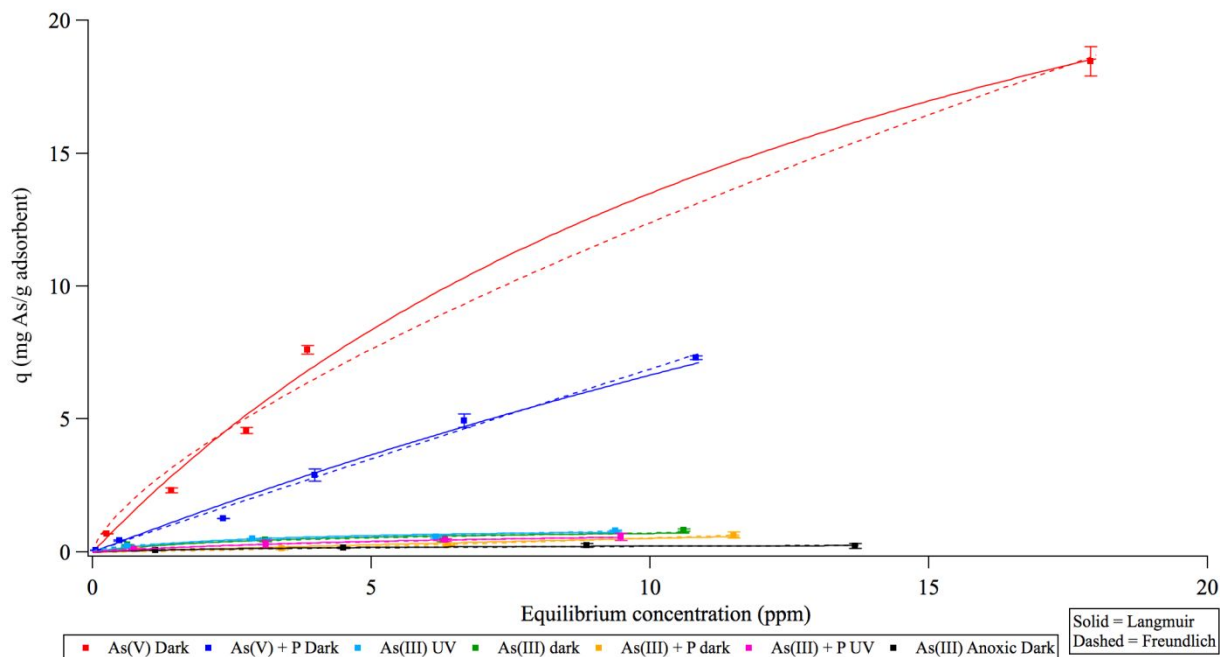


296

297 **Figure 5.** Stacked and normalized Cu K-edge XANES spectra for Cu(II)-chitosan (0.4 g Cu / g chitosan)
 298 incubated in various systems conditions.
 299

300 3.4 Analysis of arsenic removal potential of Cu(II)-chitosan and Cu(II)-n-TiO₂-chitosan

301 In order to assess the effect of the observed redox reactions on arsenic removal potential
 302 by these adsorbents, adsorption isotherms were generated for Cu(II)-chitosan (Figure 6), and the
 303 two versions (A and B) of Cu(II)-n-TiO₂ chitosan in all systems conditions (As(V), As(V) + P,
 304 As(III) dark, As(III) + P dark, As(III) UV, As(III) + P UV, and As(III) anoxic) (Figure S2 and
 305 S3). Langmuir (solid fits) and Freundlich (dashed fits) adsorption theory was used to model the
 306 data in order to determine which model more closely describes adsorption behavior. The
 307 equations of these two models can be found within the supplemental information.
 308



309

	As(V) Dark	As(V) + P Dark	As(III) UV	As(III) + P UV	As(III) Dark	As(III) + P Dark	As(III) Anoxic Dark
Langmuir							
q Max (mg/g)	35.0	37.2	0.959	0.964	0.930	0.964	0.310
b (L/mg)	0.063	0.022	0.380	0.144	0.304	0.144	0.266
Chi-square	1.25	0.390	0.013	0.001	0.063	0.001	0.001
Freundlich							
K_f	2.48	0.730	0.290	0.145	0.263	0.024	0.082
1/n	0.698	0.975	0.451	0.608	0.438	1.34	0.427
Chi-square	2.52	0.287	0.007	0.001	0.038	0.012	0.003

310

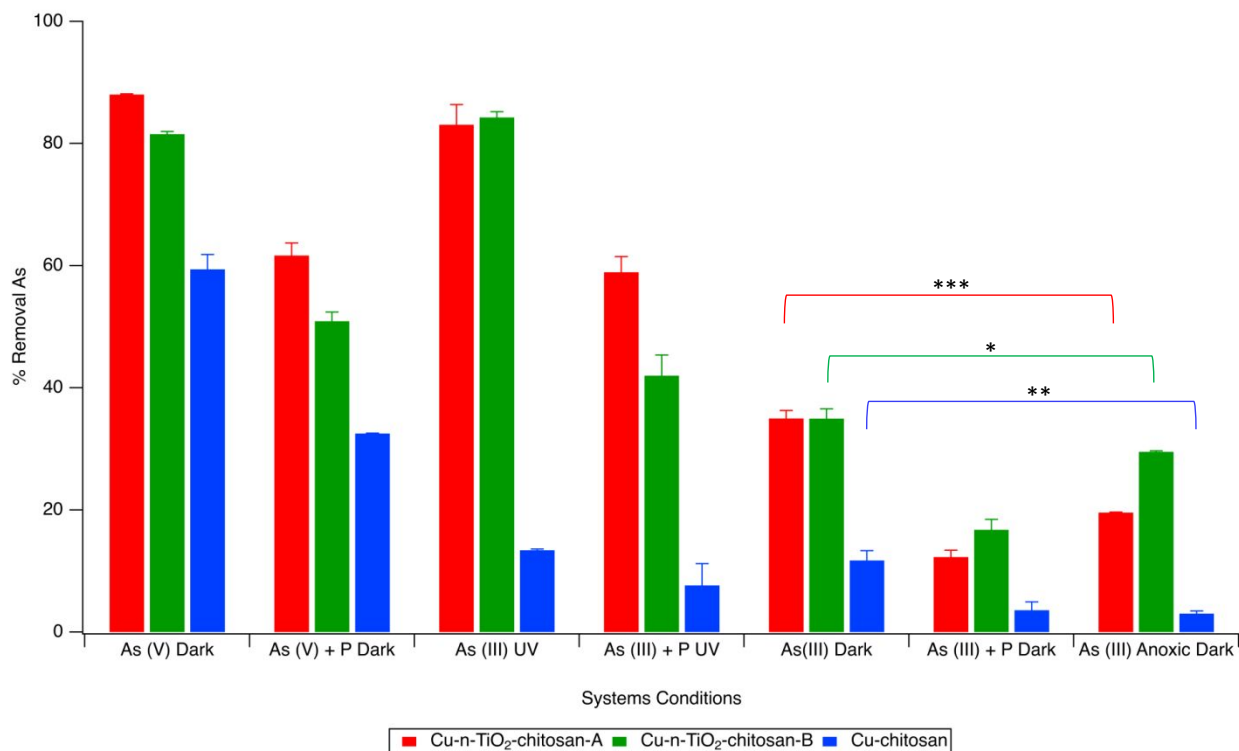
311 **Figure 6.** Adsorption isotherms and fitting parameters for arsenic removal of Cu-chitosan chitosan (0.4 g
 312 $\text{Cu}(\text{NO}_3)_2 \cdot 3\text{H}_2\text{O}$ per 1 g chitosan). Initial As concentrations were 1, 4, 8, and 12 ppm and 0.25 mM acetate
 313 buffer pH 6, for all systems except As(V) where 1, 2, 4, 8, and 40 ppm were the initial As concentrations.
 314 Phosphate concentration was 16 ppm when present. 8 W, 365 nm UV light was used where indicated.
 315 Anoxic incubation was done in a N atmosphere. Langmuir fits indicated with solid lines and Freundlich fits
 316 with dashed lines.

317

318 Overall results agree with previous findings^{21,22} that Cu(II)-chitosan is capable of
 319 selective adsorption of As(V) over phosphate. The highest As removal performance by Cu(II)-
 320 chitosan was of As(V), followed by As(V) + P (Figure 6). The remaining systems conditions had
 321 relatively low arsenic removal performance. There were slight differences in arsenic removal
 322 capability with slightly higher removal of As(III) UV followed by (listed in order of decreasing
 323 As removal performance): As(III) dark, As(III) + P dark, As(III) + P UV, and As(III) anoxic
 324 dark. All systems, with the exception of As(V), As(III) + P UV, and As(III) + P dark, were better
 325 described by the Freundlich model, as indicated by lower chi-square values. As(V) and As(III) +
 326 P dark removal performance was better described by the Langmuir model and a similar quality

327 fit was obtained using both models for As(III) + P UV. Adsorption isotherms for Cu(II)-n-TiO₂-
 328 chitosan A and B are found within the SI (Figure S2 and S3).

329



330

331 **Figure 7.** Comparison of Cu-n-TiO₂-chitosan-A (0.4 g Cu(NO₃)₂·3H₂O, 0.3 g n-TiO₂ loading / 1 g
 332 chitosan), Cu-n-TiO₂-chitosan-B (0.36 g Cu(NO₃)₂·3H₂O, 0.6 g n-TiO₂ / 1 g chitosan), and Cu-chitosan
 333 (0.4 g Cu(NO₃)₂·3H₂O per 1 g chitosan) performance. Initial concentrations were 4 ppm As and 25 mM
 334 acetate buffer pH 6, and 16 ppm P when present. Where indicated an 8W 365 nm UV light was used.
 335 Anoxic incubation was done in a N atmosphere. T-test at 95% confidence level ($p < 0.05$) showed that
 336 these changes in As(III) removal are statistically significant for Cu(II)-chitosan **(p value = 0.035) and
 337 Cu(II)-n-TiO₂-chitosan-A ***(p value = 0.007), but not Cu(II)-TiO₂-chitosan B *(p value = 0.07) which
 338 contained more n-TiO₂ than Cu(II), so was less affected by the change in environmental conditions.

339

340 Comparing all three adsorbents, the adsorbent with the greatest arsenic removal
 341 capability in all systems conditions examined was Cu(II)-n-TiO₂-chitosan A followed by Cu(II)-
 342 n-TiO₂-chitosan B, and finally Cu(II)-chitosan (Figure 7). Cu(II)-n-TiO₂-chitosan A
 343 outperformed Cu(II)-n-TiO₂ B due to it having more optimal ratios of both active components
 344 (Cu and n-TiO₂), enough Cu(II) to selectively remove As and enough n-TiO₂ to effectively
 345 photo-oxidize As(III) to the more easily adsorbed As(V).^{18,21} Cu(II)-chitosan was not as effective
 346 at arsenic removal due to its inability to photo-oxidize As(III) to As(V) in UV light.

347 Critically, it was found that the observed Fenton-like reaction significantly impacts the
 348 adsorption capacity of Cu(II)-chitosan and Cu(II)-n-TiO₂-chitosan towards As(III). Comparing

349 As(III) removal in oxic and anoxic conditions, Cu(II)-n-TiO₂-chitosan A saw a 75% increase
350 (35% up from 20%), in As(III) removal in oxic vs anoxic conditions and Cu(II)-n-TiO₂-chitosan
351 B a 16% increase (35% up from 30%). Similarly, Cu(II)-chitosan removed 11.8% of As(III) in
352 oxic conditions, but only 3.1% in anoxic conditions, suggesting a 280% increase in As(III)
353 removal capability.

354 Likely, the decreased effect of anoxic conditions on As(III) removal by Cu(II)-n-TiO₂-
355 chitosan B is due to its lower loading of Cu(II) and higher loading of n-TiO₂ compared to both
356 Cu(II)-n-TiO₂-chitosan A and Cu(II)-chitosan. As suggested by the XANES analyses (Figure 3),
357 if oxidation of As(III) to As(V) via the proposed Fenton-like mechanism occurs solely at Cu(II)
358 binding sites, then we would expect that the higher loading of n-TiO₂-chitosan in adsorbent B
359 would lead to less Fenton-like oxidation of As(III). Thus, the change from oxic to anoxic
360 conditions has less of an effect on As(III) removal for Cu(II)-n-TiO₂-chitosan B than Cu(II)-n-
361 TiO₂-chitosan A and Cu(II)-chitosan. Cu(II)-n-TiO₂-chitosan A is less affected than Cu(II)-
362 chitosan as it does have some n-TiO₂ binding sites for As(III) which will not be affected by the
363 change from oxic to anoxic conditions.

364

365 3.5 Conclusion

366 Through this work we have observed that Cu(II)-chitosan is capable of effectively
367 oxidizing As(III) to As(V) through a Fenton-like reaction. Both Cu(II) and chitosan contribute
368 to this reaction mechanism, Cu(II) as a catalyst, and chitosan as a reducing agent. This oxidation
369 reaction significantly enhances the As(III) removal performance of Cu(II)-chitosan and Cu(II)-n-
370 TiO₂-chitosan. The ability of Cu(II)-chitosan and Cu(II)-n-TiO₂-chitosan to oxidize As(III) to
371 As(V) simultaneous with arsenic removal enables the elimination of a traditional pre-treatment
372 oxidation step, and thus, may increase the cost efficiency of these adsorbents compared to
373 traditional non-multifunctional materials. The use of chitosan, a natural waste product of the
374 shellfish industry, also has the potential to enhance cost-effectiveness of these adsorbents.

375 Increased understanding of As(III) oxidation via Fenton-like reactions could help to
376 elucidate arsenic interactions with metal-organic complexes in aqueous and terrestrial
377 environments, as well as within the human body. As arsenic is a probe molecule to explore the
378 mechanism of Cu(II)-chitosan Fenton-like reactions, this system has widespread potential uses in
379 participating in redox reactions of other inorganic contaminants of interest such as elemental

380 mercury and hexavalent chromium. Fenton-like reactions hold great promise in their ability to
381 oxidize or reduce inorganic contaminants (e.g. chromium) into their less toxic and/or more easily
382 removed oxidation states.

383 Increased knowledge about the ability of Fenton and Fenton-like reactions to oxidize
384 inorganic contaminants will enable their use within more realistic, mixed organic/inorganic
385 contaminant systems. Fenton and Fenton-like reactions have been widely utilized to oxidize
386 organic compounds into less toxic or more easily biodegradable molecules, however oxidation of
387 inorganics has been much less frequently studied. Incorporation of a simultaneous ability to
388 oxidize inorganics and organics, without the need for an external oxidant such as H₂O₂ or UV
389 light, can increase the economic feasibility of these oxidation techniques as well as the variety of
390 systems in which these techniques will be effective.

391

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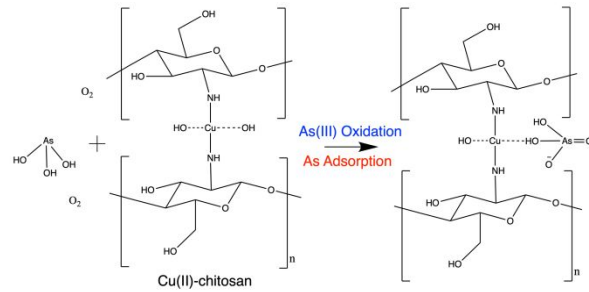
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Simultaneous oxidation of As(III) to As(V) and adsorption of As(V) by Cu(II)-chitosan. Arsenic oxidation occurs via a Cu(II)-chitosan catalyzed Fenton-like reaction.